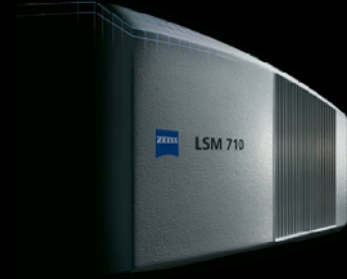


Invitation

Workshop LSM 510 META



www.zeiss.de/sensitivity

The New Dimension in Confocal Laser Scanning Microscopy

- Laser Scanning Microscopy Principles :
- Introduction to the Confocal Microscopy
 - LSM Principles and Applications
 - Carl Zeiss LSM 510 META and LSM 710 laser scanning microscope systems

23 March 2011

Application Specialists:
Annette Bergter

Iko Katayama

Location:

Bilkent University UNAM -
Institute of Materials Science and Nanotechnology

Address: 06800 Bilkent, Ankara

Telephone: +90 (312) 290 2513

+90 (312) 290 2513

Fax: +90 (312) 266 4365

Mail: <http://www.nano.org.tr>



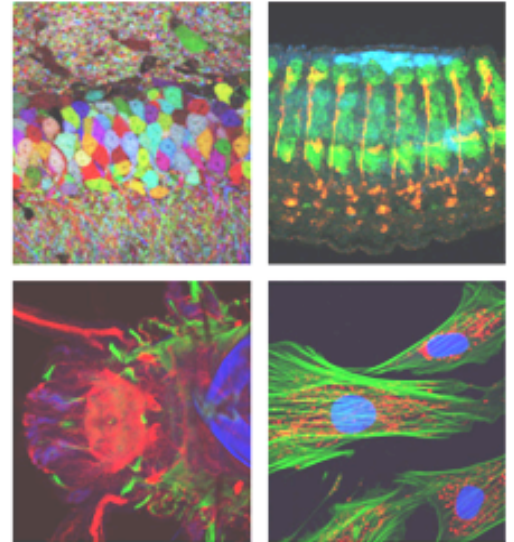
INSTITUTE OF MATERIALS SCIENCE AND NANOTECHNOLOGY
NATIONAL NANOTECHNOLOGY RESEARCH CENTER PROJECT



Registration

Fax: +90 312 447 65 78

Mail: hasan_eser@optronik.com



OPTRONİK LTD. ŞTİ.
Reşit Galip Caddesi İlk Adım Sokak
No:18 G.O.P. ANKARA

TEL: 00 90 312 447 47 53

FAX: 00 90 312 447 65 78

GSM:00 90 530 314 35 01

e-mail: optronik@optronik.com

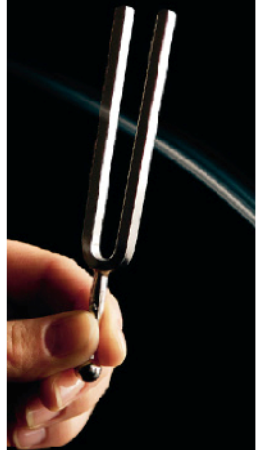


We make it visible.

Workshop LSM 510 META

The New Dimension in Confocal Laser Scanning Microscopy

- | | |
|-------|---|
| 09:00 | Welcome adress |
| 09:15 | 3D Optical Sectioning Family |
| 10:15 | Coffee break |
| 10:45 | Applications in Multiphoton Microscopy |
| 11:15 | Tuning Imaging Parameters for Fluorescence Microscopy |
| 12:00 | Lunch break |
| 13:00 | 1. Demonstration Session |
| 14:30 | 2. Demonstration Session |
| 16:00 | 3. Demonstration Session |
| 18:00 | Farewell adress |



We make it visible.